

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Moon, et al

Serial No.: 10/025,144

Confirmation No.: 5051

Filed:

December 18, 2001

For:

Method and Apparatus for

Polishing Metal and **Dielectric Substrates** 

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 2813

Examiner:

Stephen W. Smoot

## **CERTIFICATE UNDER 37 CFR 1.10**

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on 10/28 , 2003, with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV335471025US addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

10/10/2013 Date

## PRELIMINAY AMENDMENT

Prior to examining the above-referenced application, the Applicants request the application be amended as follows. Amendments to the Claims begin on page 2 of this paper. Remarks begin on page 10 of this paper.